Small Business Innovation Research/Small Business Tech Transfer

An Implant-Passivated Blocked Impurity Band Germanium Detector for the Far Infrared, Phase I



Completed Technology Project (2010 - 2010)

Project Introduction

We propose to investigate the feasibility of fabricating a germanium blockedimpurity-band (BIB) detector using a novel process which will enable us to: 1fabricate a suitably-doped active layer using the well-established bulk crystalgrowth process, which guarantees excellent dopant control and extremely low compensating impurities, and 2- grow the blocking layer using an implantpassivation technique which will produce the required high purity and a very sharp transition from the active to blocking layer. These features are key in design and optimization of multi-layered structure of BIBs, and their implementation and quality are crucial in optimum operation of these detectors. The proposed process is a drastic departure from conventional epitaxial methods, such as chemical vapor deposition and liquid phase epitaxy, which have yet to produce far IR BIBs suitable for astronomical instruments. Germanium BIBs will offer extended wavelength response to at least 200µm, high quantum efficiency, high immunity to ionizing radiation, and elimination of long-term transient and memory effects. Coupled with their compatibility with Si cryo-CMOS readout multiplexers and the planar, bump-bond hybridization process, these detectors will make possible the construction of large format, high sensitivity FPAs for far IR astronomy and will replace the current unstressed and stressed germanium detectors.

Primary U.S. Work Locations and Key Partners





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Organizations Performing Work	Role	Туре	Location
TechnoScience	Lead	Industry	Palo Alto,
Corporation	Organization		California
Jet Propulsion	Supporting	NASA	Pasadena,
Laboratory(JPL)	Organization	Center	California

Primary U.S. Work Locations

California

Project Transitions

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January 2010: Project Start



July 2010: Closed out

Closeout Documentation:

• Final Summary Chart(https://techport.nasa.gov/file/139997)

Organizational Responsibility

Responsible Mission Directorate:

Space Technology Mission Directorate (STMD)

Lead Organization:

TechnoScience Corporation

Responsible Program:

Small Business Innovation Research/Small Business Tech Transfer

Project Management

Program Director:

Jason L Kessler

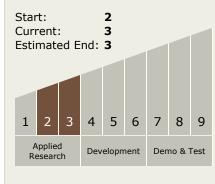
Program Manager:

Carlos Torrez

Principal Investigator:

Jam Farhoomand

Technology Maturity (TRL)





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Technology Areas

Primary:

- TX08 Sensors and Instruments
 - ☐ TX08.1 Remote Sensing Instruments/Sensors
 - ☐ TX08.1.1 Detectors and Focal Planes

Target Destinations

The Sun, Earth, The Moon, Mars, Others Inside the Solar System, Outside the Solar System

